



PATENT
ATTORNEY DOCKET NO.: 053785-5157

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Young-Joo KIM)	
)	
U.S. Application No.: 10/717,676)	Group Art Unit: Unassigned
)	
Filed: November 21, 2003)	Examiner: Unassigned
)	
For: METHOD OF CRYSTALLIZING AMORPHOUS)	
SILICON AND DEVICE FABRICATED USING)	
THE SAME)	

The Commissioner of Patents
Arlington, VA 22202

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicant brings to the attention of the Examiner the document listed on the attached PTO-1449. To the best of the undersigned's knowledge, this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application. Accordingly, Applicant does not believe that a fee is due for filing this paper.

The listed document may be pertinent for the reasons discussed at page 7, paragraph [0012] of the specification. A copy of the listed document is attached.

Applicant respectfully requests that the Examiner consider the listed document and evidence that consideration by making appropriate notations on the attached form.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "prior art." If it should be determined that the listed document does not constitute "prior art" under


United States law, Applicant reserves the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

Except for issue fees payable under 37 C.F.R. § 1.18, the Commissioner is hereby authorized by this paper to charge any additional fees during the entire pendency of this application including fees due under 37 C.F.R. §§ 1.16 and 1.17 which may be required, including any required extension of time fees, or credit any overpayment to Deposit Account 50-0310. This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENSION OF TIME** in accordance with 37 C.F.R. § 1.136(a)(3).

Respectfully submitted,

MORGAN, LEWIS & BOCKIUS LLP

By: 
David B. Hardy
Reg. No. 47,362

Dated: February 19, 2004

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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

PTO Form 1449

Attorney Docket No.

053785-5157

Application No.

10/717,676

Applicant: Young-Joo KIM

Filing Date: November 21, 2003

Group Art Unit: Unassigned

U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	<u>Translation</u> YES NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	<i>Single-Crystal Si Films Via a Low-Substrate-Temperature Excimer-Laser Crystallization Method, R Sposili, et al. Mat. Res. Soc. Symp. Proc. Vol. 542, 956, pp 953-958.</i>

Examiner

Date Considered

Examiner:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DBH/fdb

February 19, 2004

Page 1 of 1